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CONFIRMATION NO. 8486

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/646,533	08/22/2003	156	2893	6915 P02
RULE				
APPLICANTS Kenneth S. Collins, San Jose, CA; Hiroji Hanawa, Sunnyvale, CA; Kartik Ramaswamy, Santa Clara, CA; Andrew Nguyen, San Jose, CA; Amir Al-Bayati, San Jose, CA; Biagio Gallo, Los Gatos, CA; Gonzalo Antonio Monroy, San Francisco, CA;				
** CONTINUING DATA ***** This application is a CIP of 10/164,327 06/05/2002 PAT 6,939,434				
** FOREIGN APPLICATIONS *****				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/17/2003				
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /JACK S J CHEN/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY CA	SHEETS DRAWINGS 85	TOTAL CLAIMS 89
				INDEPENDENT CLAIMS 1
ADDRESS Pantent Counsel, M/S 2061 Legal Affairs Dept. Applied Materials, Inc. P.O. Box 450-A Santa Clara, CA 95035 UNITED STATES				
TITLE Plasma immersion ion implantation process using a plasma source having low dissociation and low minimum plasma voltage				
FILING FEE RECEIVED 2142	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees	
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